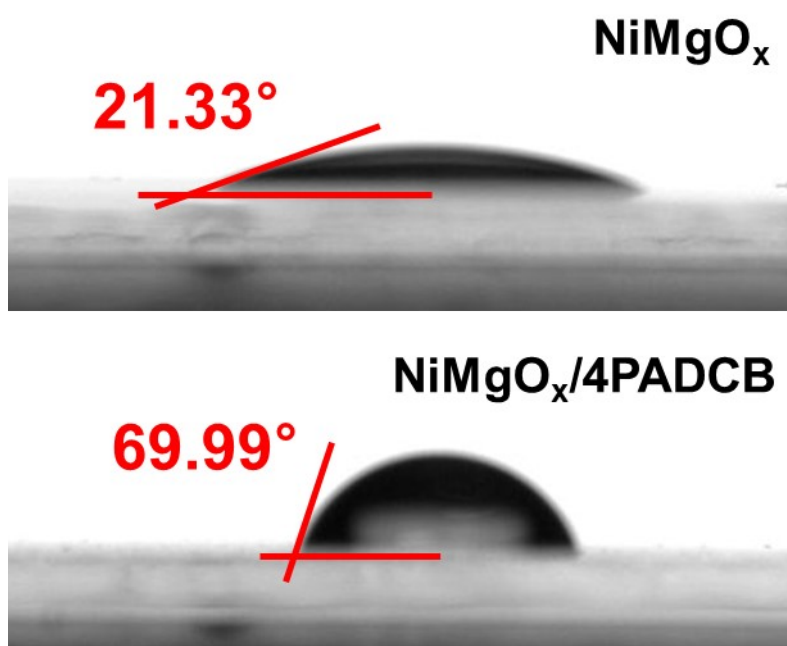


Supporting information

**Interface-modified NiMgO<sub>x</sub> Layers with Dibenzocarbazole Molecules for  
High-Efficiency Perovskite Light-Emitting Diodes**

*Hyungdoh Lee, Jun-Seo Lee, Seungmin Shin, Wonjeong Yu, In Hye Kwak, Hyung Joong Yun,  
Seungbum Hong, and Himchan Cho\**

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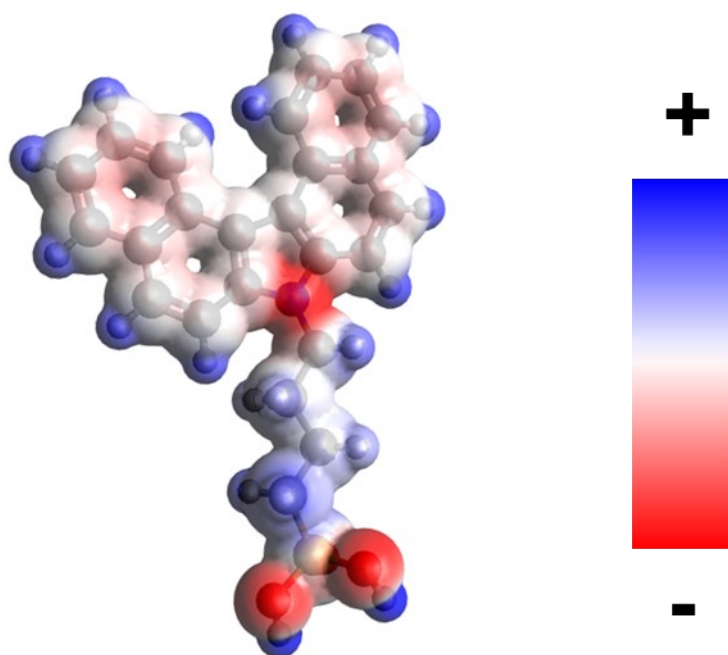
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15 **Figure S1.** Water contact angle of NiMgO<sub>x</sub> surface with and without 4PADCB interlayers.

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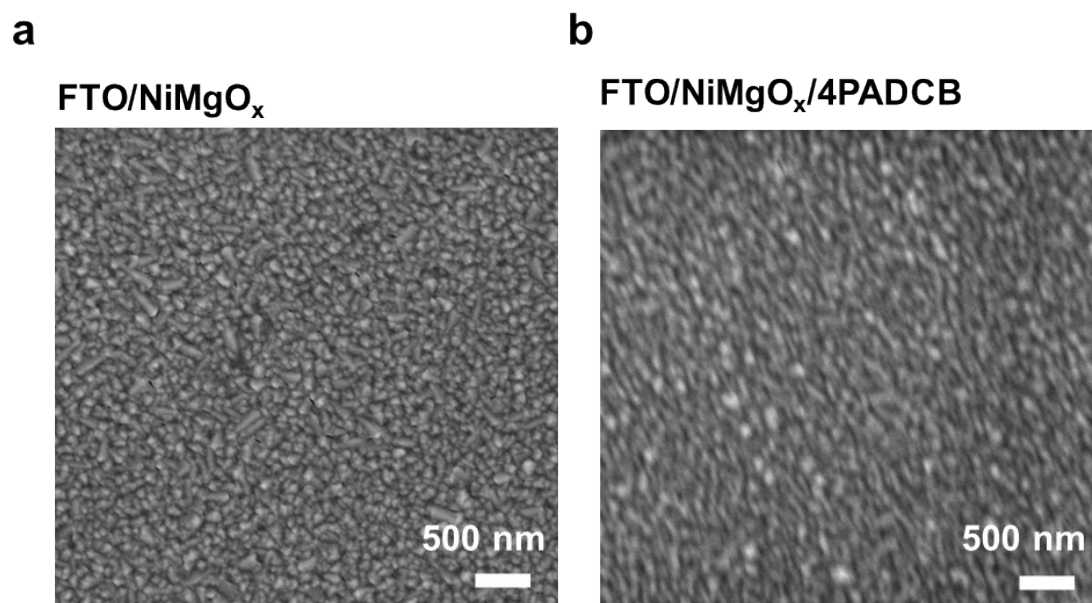
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21 **Figure S2.** Electrostatic potential (ESP) mapping image of 4PADCB molecule.

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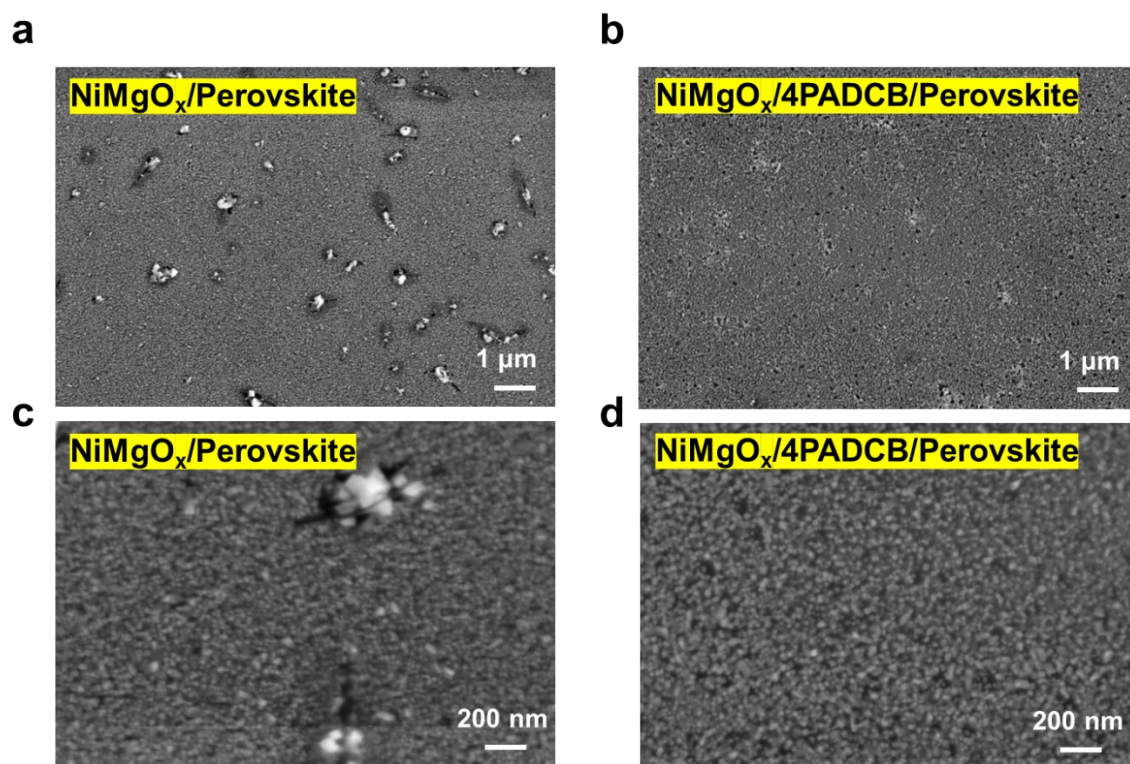
27 **Figure S3.** Scanning electron microscopy (SEM) image of (a) FTO/NiMgO<sub>x</sub> and (b)  
28 FTO/NiMgO<sub>x</sub>/4PADCB surface.

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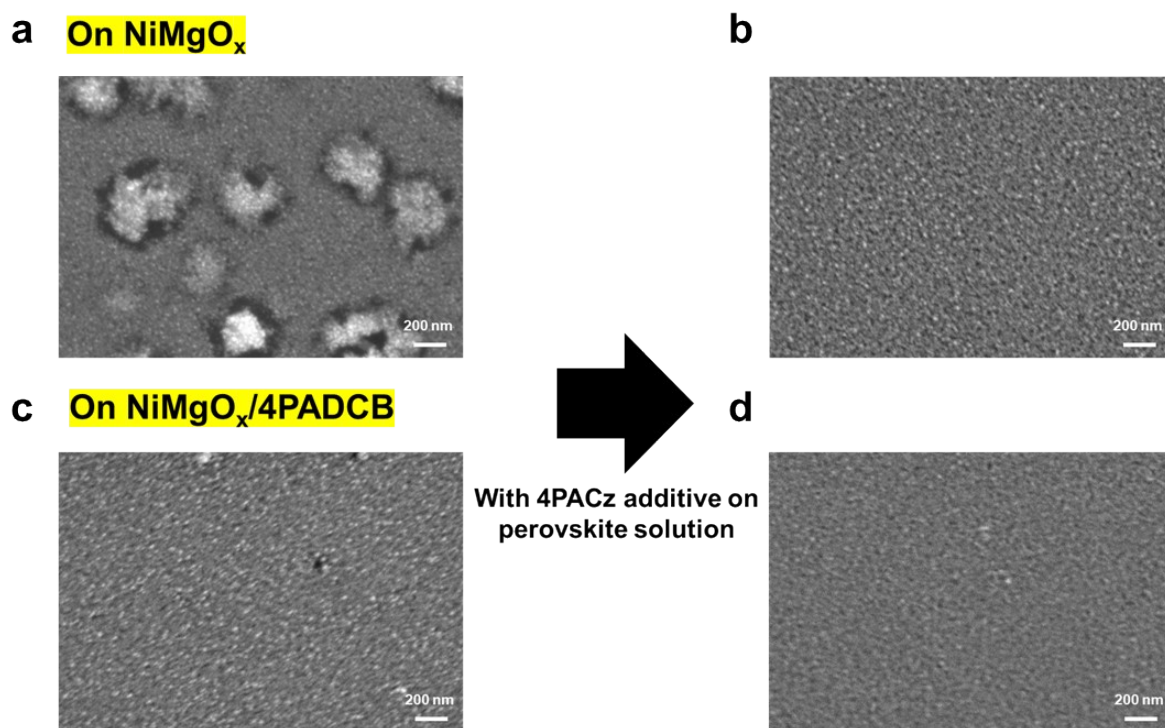
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35 **Figure S4.** Surface morphology analysis of perovskite films deposited on different underlying  
36 layers. a) Scanning Electron Microscopy (SEM) image of the perovskite film surface on the  
37 pristine NiMgO<sub>x</sub> substrate and b) on the NiMgO<sub>x</sub>/4PADCB surfaces. c) High-magnification  
38 SEM image of the perovskite surface on NiMgO<sub>x</sub> and d) on NiMgO<sub>x</sub>/4PADCB.

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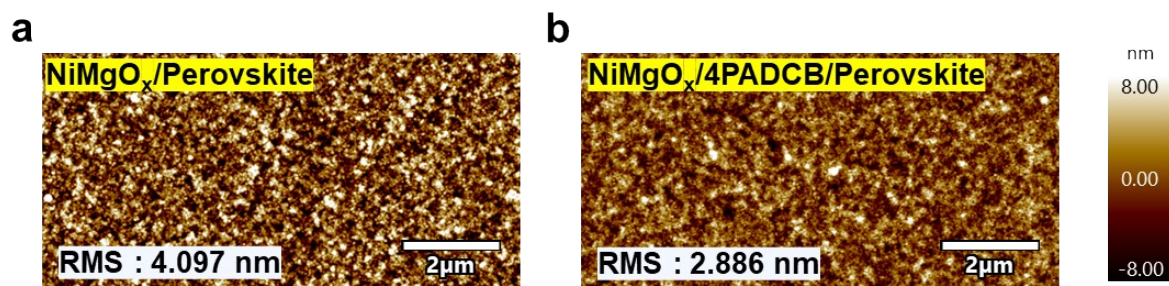
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44 **Figure S5.** SEM analysis of perovskite film morphology showing films fabricated a,c) without  
 45 and b,d) with the 4PACz additive in perovskite precursor solution, comparing deposition on  
 46 a,b) the pristine  $\text{NiMgO}_x$  and c,d) the  $\text{NiMgO}_x/4\text{PADCBC}$  surfaces.

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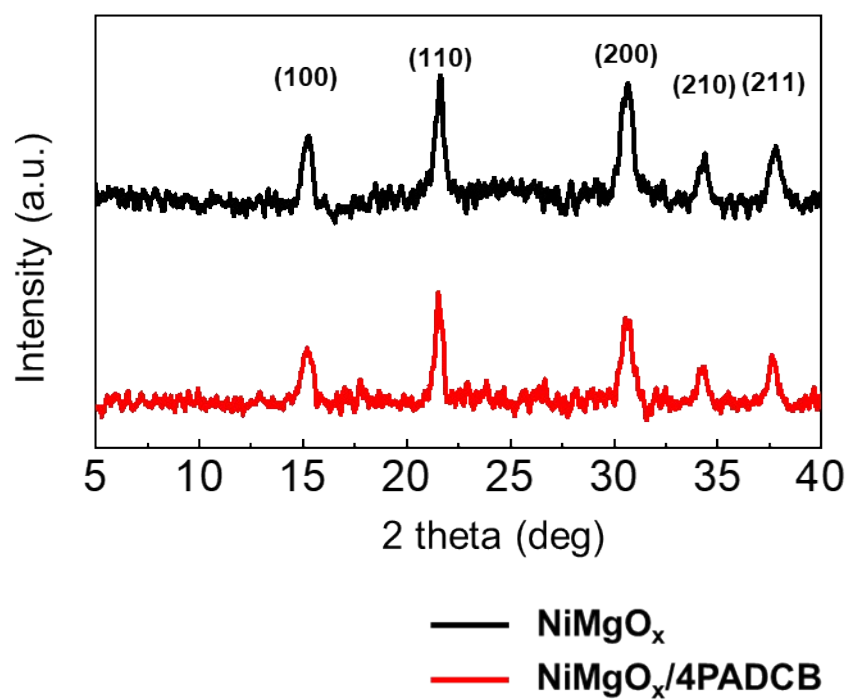
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**Figure S6.** Surface topography analysis of perovskite films via Atomic Force Microscopy (AFM). a) AFM image and corresponding surface roughness data for the perovskite film deposited on the pristine NiMgO<sub>x</sub> layer and b) on the NiMgO<sub>x</sub>/4PADCB interface.

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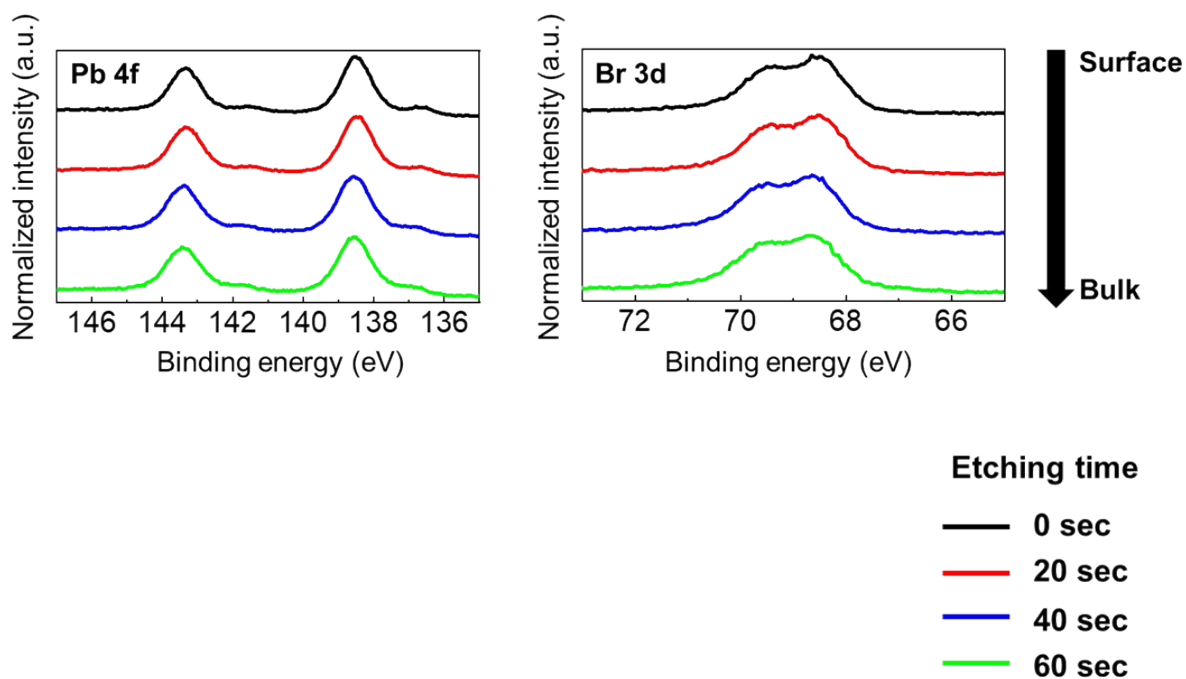
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61 **Figure S7.** XRD spectra of perovskite on  $\text{NiMgO}_x$  and  $\text{NiMgO}_x/4\text{PADCB}$  layers.

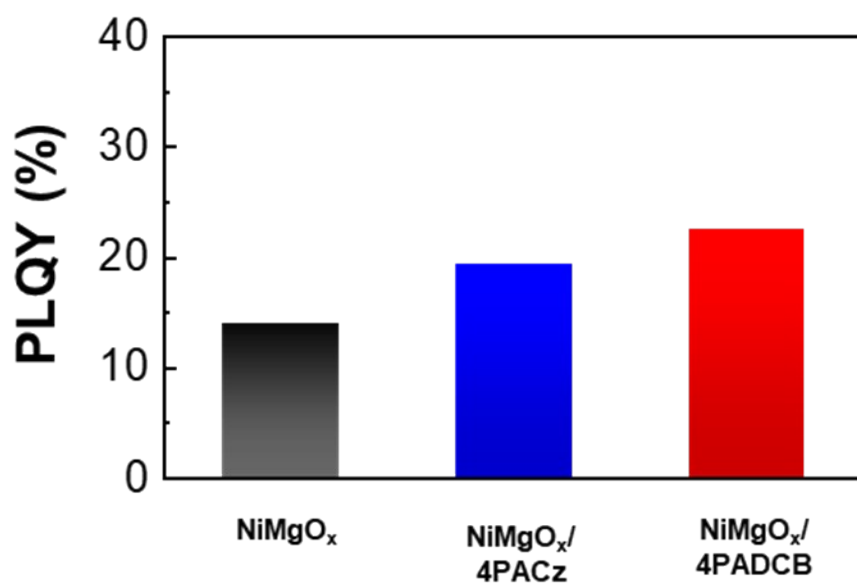
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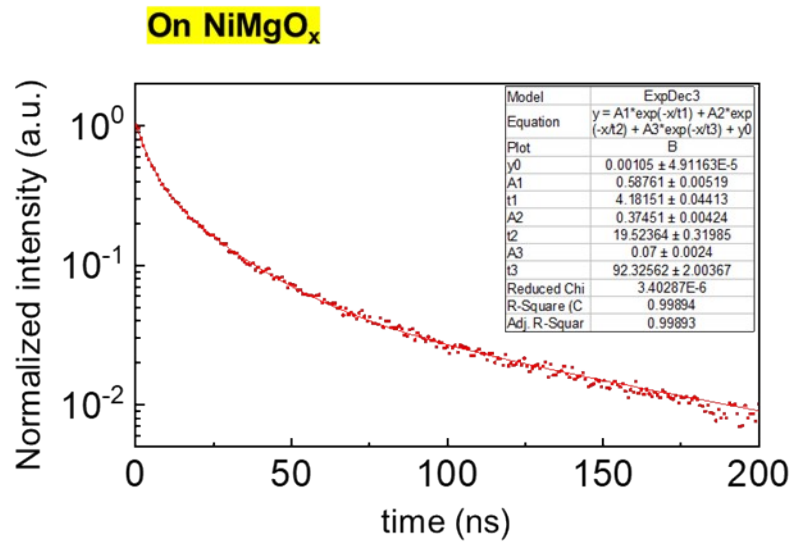
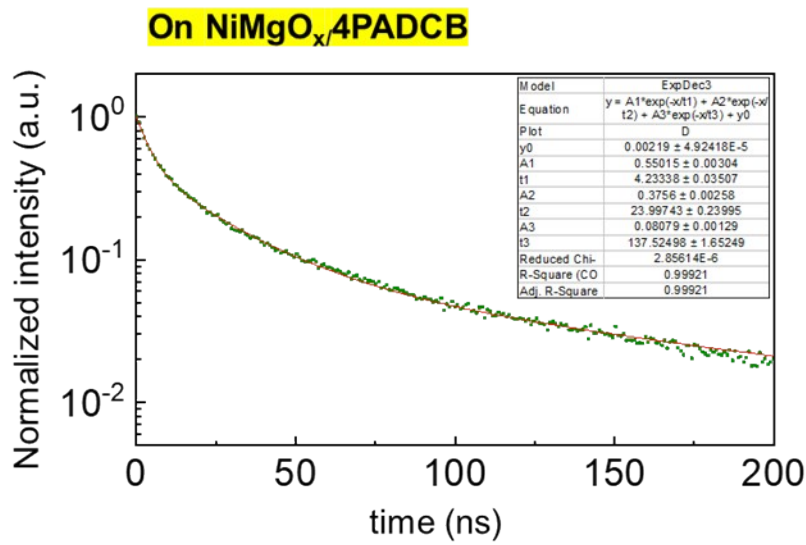


**Figure S8.** XPS depth profile analysis showing the evolution of the Pb 4f and Br 3d core-level spectra with etching time on NiMgO<sub>x</sub>/4PADCB surface.



**Figure S9.** Photoluminescence quantum yield (PLQY) of perovskite on NiMgO<sub>x</sub> with and without SAM interlayers.

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**a****b**

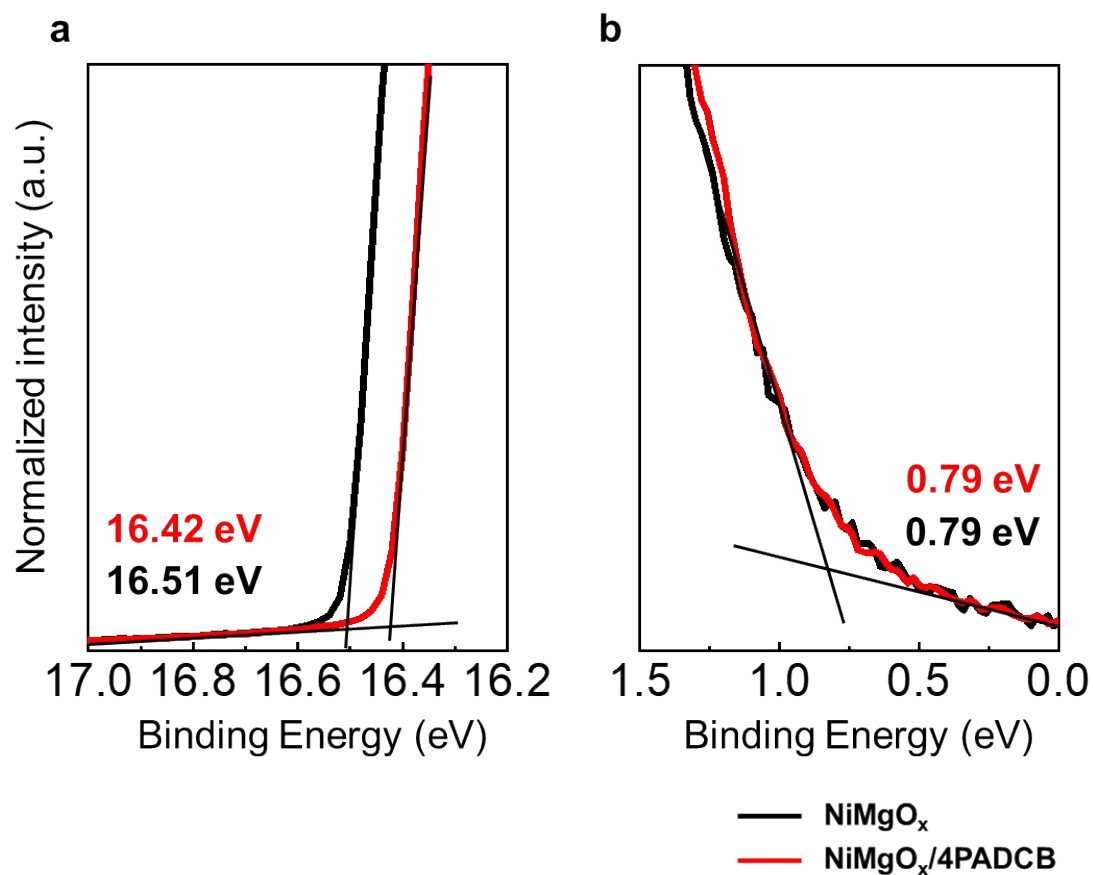
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**Figure S10.** TrPL fitting data using a tri-exponential decay method. The fitting sample is perovskite on (a) NiMgO<sub>x</sub>, and (b) NiMgO<sub>x</sub>/4PADCB layers.

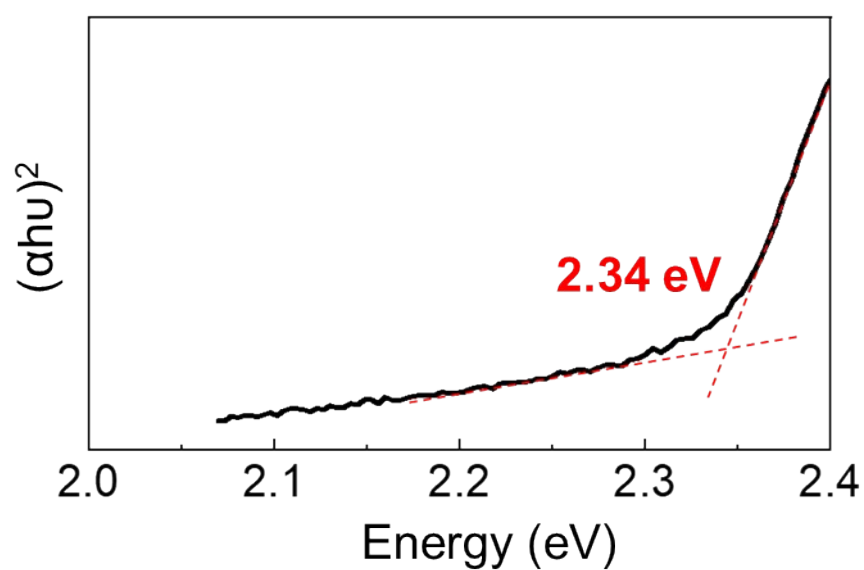
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**Figure S11.** UPS spectra of perovskite on NiMgO<sub>x</sub> and NiMgO<sub>x</sub>/4PADCB layers. (a) Secondary cut-off and (b) edge regions of spectra.

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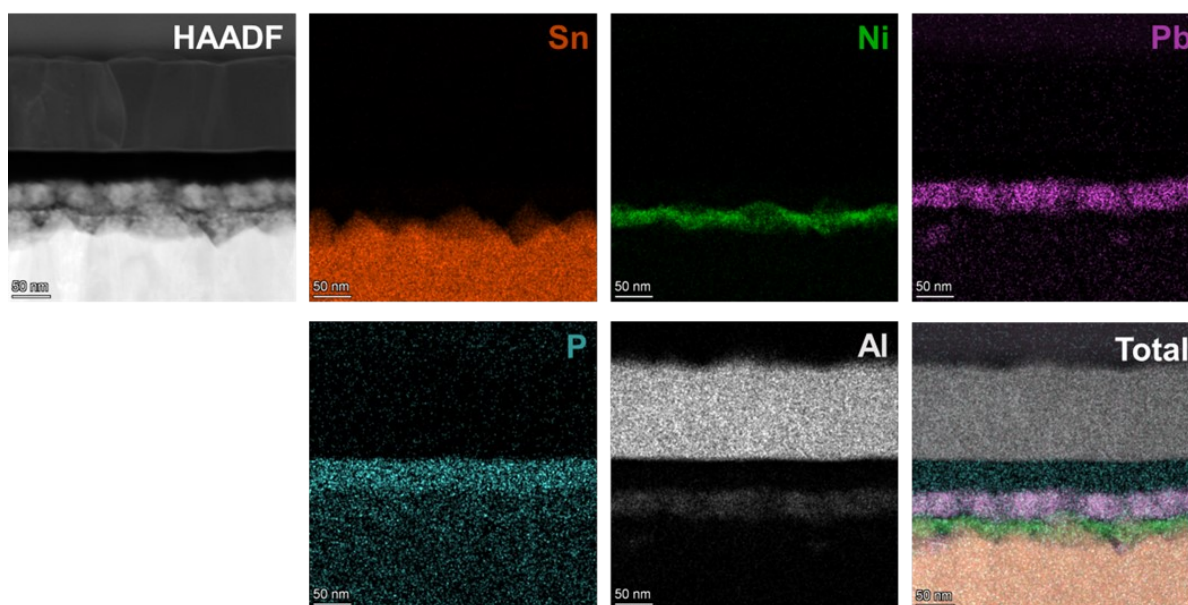
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95 **Figure S12.** Tauc plot of the perovskite layers, showing an optical bandgap of 2.34 eV,  
96 consistent with the green emission region.

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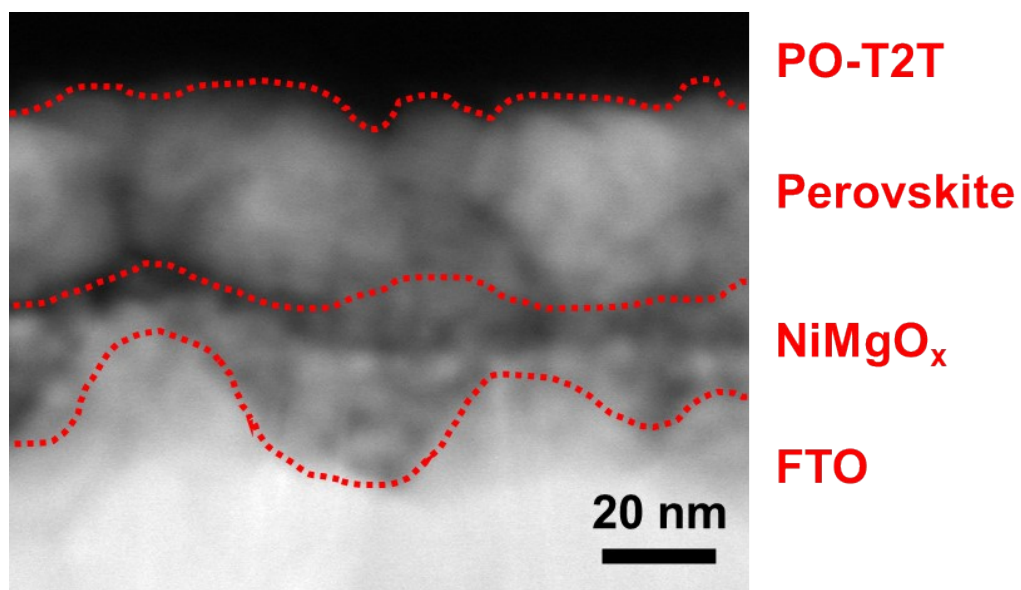
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102 **Figure S13.** High-angle annular dark-field (HAADF) image and EDS spectra of the PeLED.  
103 Each layer is successfully deposited, as evidenced by the distinct elemental distributions.

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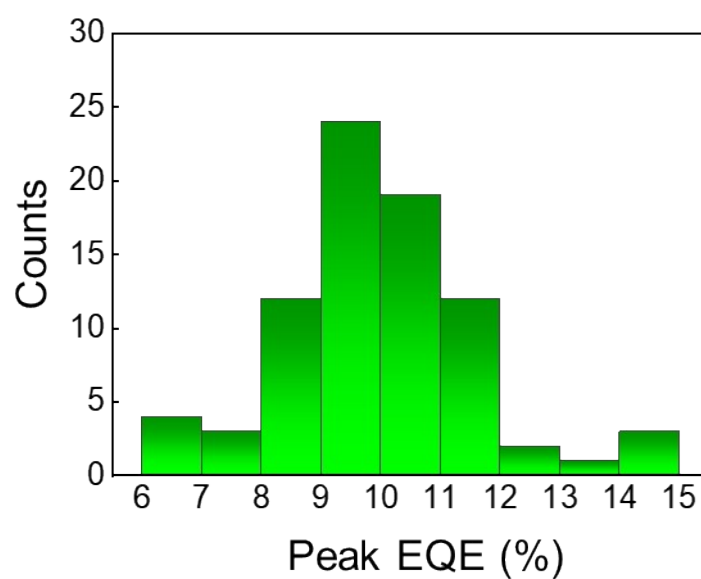
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109 **Figure S14.** High-magnification cross-sectional STEM image of the PeLED, showing clearly  
110 distinguishable layers.

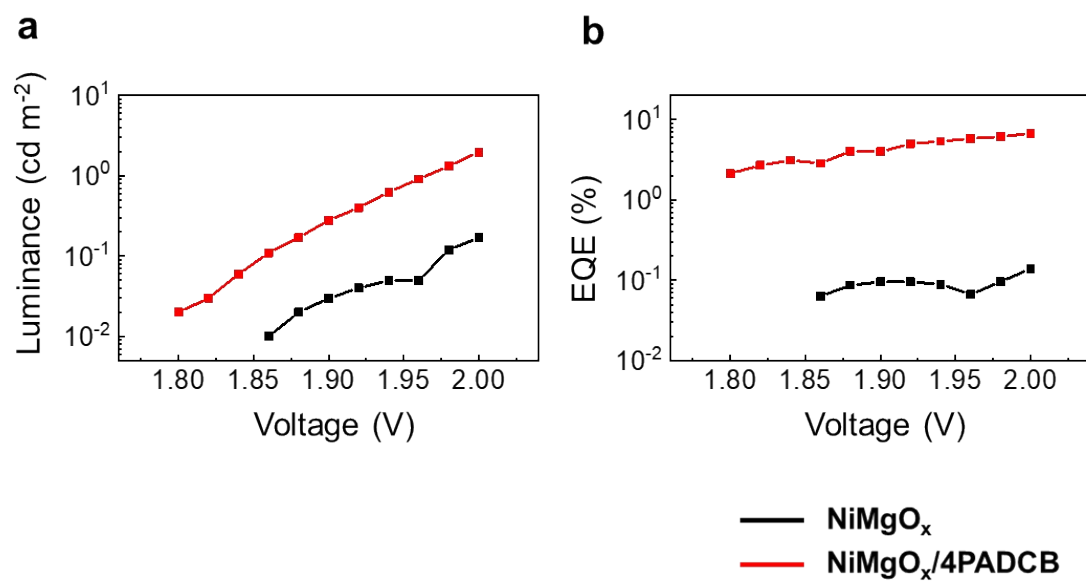
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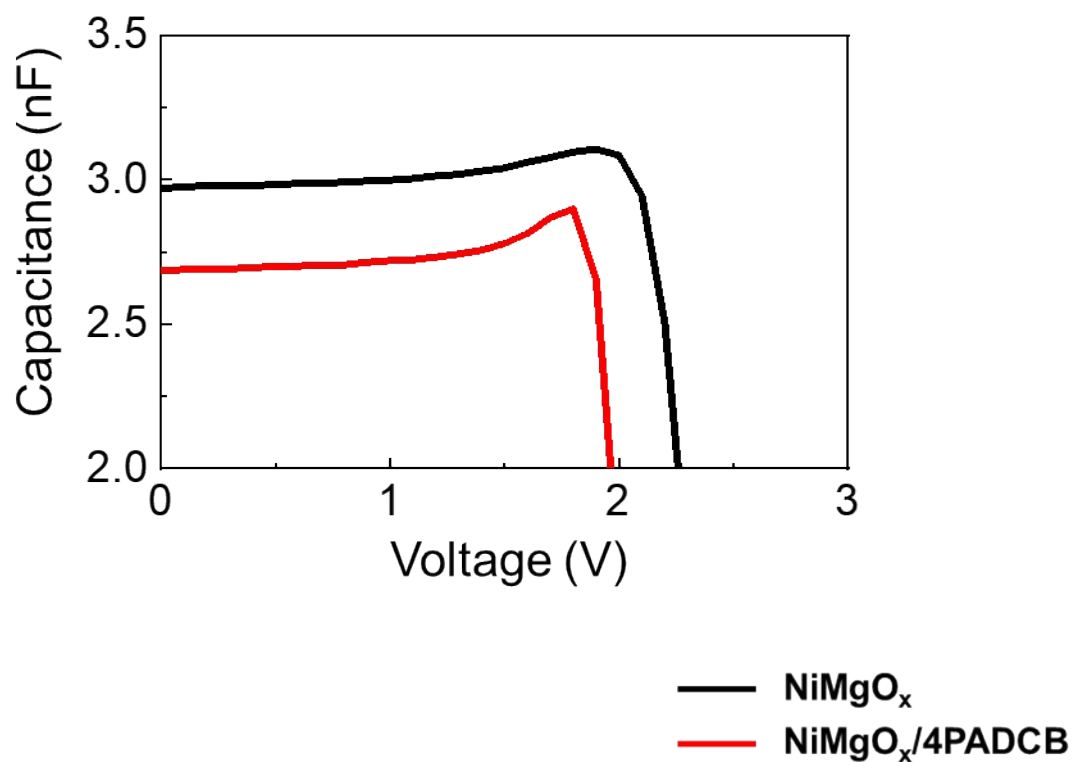
**Figure S15.** Histogram of peak EQE for 80 devices with the 4PADCB interlayer (FTO/NiMgO<sub>x</sub>/4PADCB/perovskite/PO-T2T/LiF/Al). The average EQE is 10.0%.





**Figure S16.** (a) Luminance and (b) EQE relationship at low operating voltage ( $\sim 2$  V) w/ and w/o 4PADCB interlayers.

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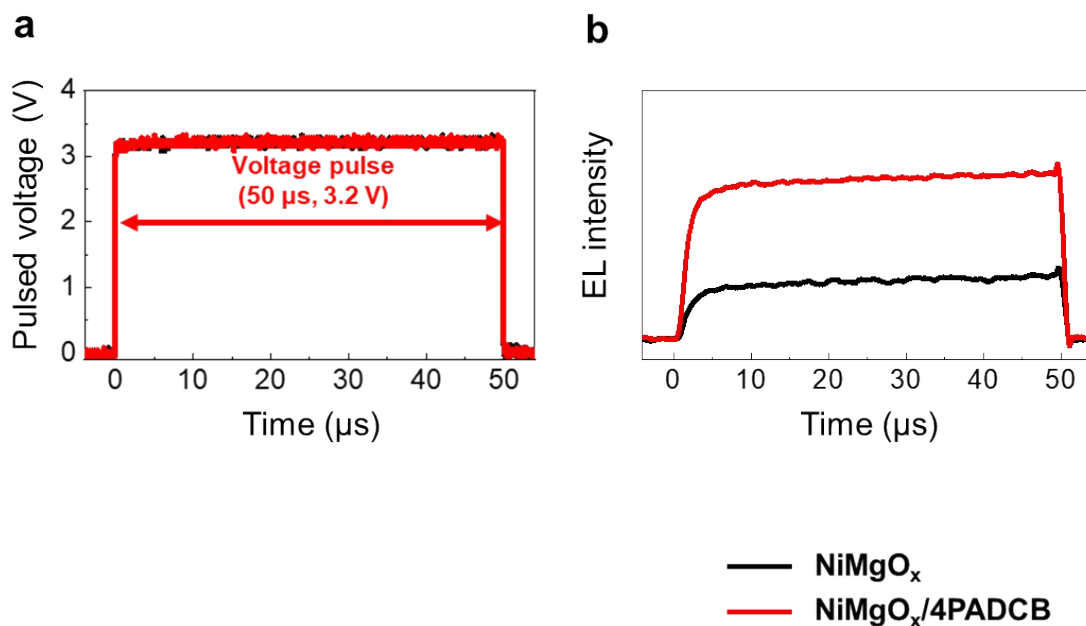
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130 **Figure S17.** The capacitance-voltage (C-V) relationship of PeLED w/ and w/o 4PADCB  
131 interlayers.

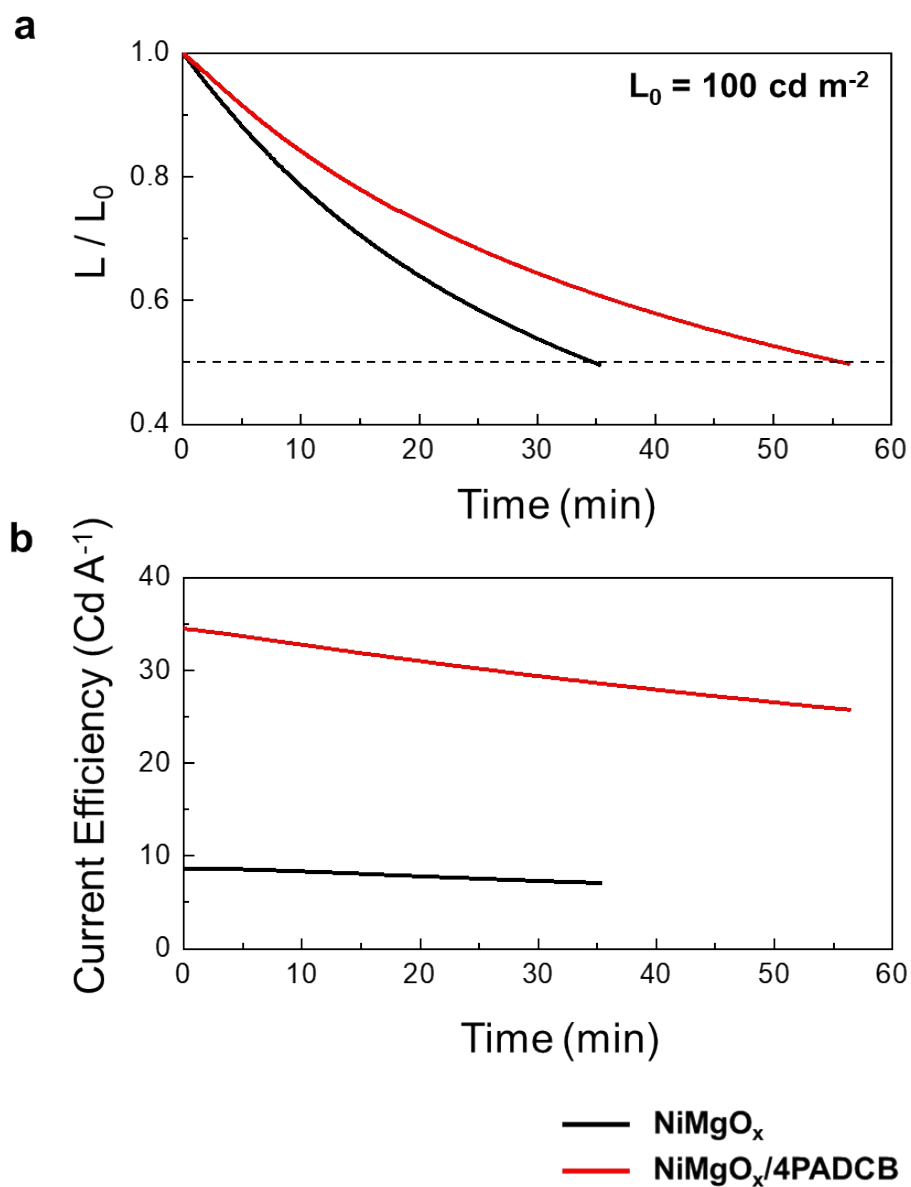
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**Figure S18.** Pulsed voltage and time relationship during TrEL measurements. (a) the pulsed voltage was 3.2 V with 50 μs periods and (b) absolute transient EL (TrEL) spectra w/ and w/o the 4PADCB interlayer.

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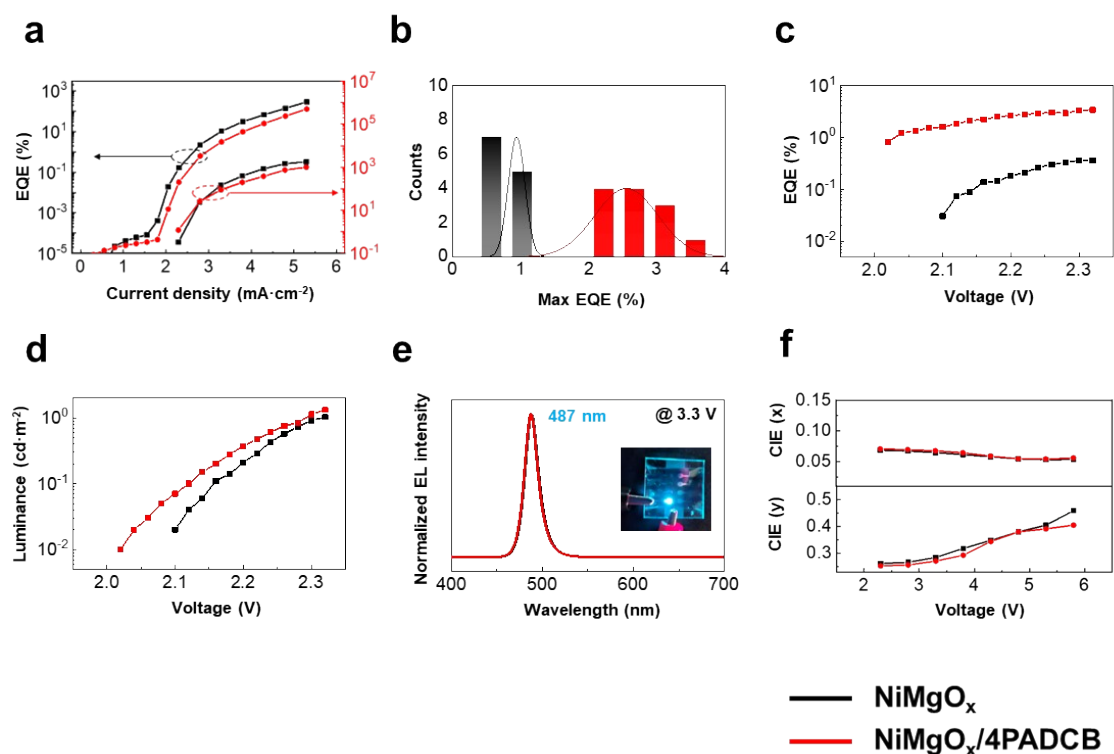
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147 **Figure S19.** Device stability test with time variation. The results indicate (a) luminance-time  
 148 (L-t) relationship and (b) current efficiency-time (CE-t) relationship.

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**Figure S20.** Sky-blue PeLED characterization w/ and w/o 4PADCB interlayer molecules. (a) J-V-L characteristics and (b) derivation of maximum EQE. (c) EQE and (d) luminance curves in the sub-bandgap voltage region (~2.3 V) for each device. (e) Normalized electroluminescence (EL) spectra at a 3.3 V bias and demonstration image of sky-blue PeLEDs with and without 4PADCB interlayers. (f) Color stability evaluated by CIE coordinate shift under bias.

	$\lambda_{\text{PL}}$ (nm)	$A_1$	$\tau_1$ (ns)	$A_2$	$\tau_2$ (ns)	$A_3$	$\tau_3$ (ns)	$\tau_{\text{avg}}$ (ns)	$R^2$
On $\text{Ni}_{0.9}\text{Mg}_{0.1}\text{O}_x$	521	0.587	4.18	0.374	19.52	0.07	92.32	46.2	0.999
On $\text{Ni}_{0.9}\text{Mg}_{0.1}\text{O}_x/4\text{PADCB}$	521	0.550	4.23	0.375	23.99	0.081	137.5	77.9	0.999

**Table S1.** Fitting parameter summary of TrPL curves. TrPL fitting was performed using tri-exponential decay curve which composed fast-decay ( $A_1$ ,  $\tau_1$ ), moderate-decay ( $A_2$ ,  $\tau_2$ ) and slow-decay ( $A_3$ ,  $\tau_3$ ). The fast-decay component is related to non-radiative recombination by trap state, whereas moderate and slow decay are related to radiative recombination, respectively. The average PL lifetime ( $\tau_{\text{avg}}$ ) is calculated from formula

$$\tau_{\text{avg}} = \frac{A_1\tau_1^2 + A_2\tau_2^2 + A_3\tau_3^2}{A_1\tau_1 + A_2\tau_2 + A_3\tau_3}.$$

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	$\lambda_{\text{EL}}$ (nm)	$V_{\text{on}}$ at 1 $\text{cd m}^{-2}$ (V)	$L_{\text{max}}$ ( $\text{cd m}^{-2}$ ) (at bias (V))	$\text{EQE}_{\text{max}}$ (%) (at bias (V))	$\text{CE}_{\text{max}}$ ( $\text{cd A}^{-1}$ ) (at bias (V))	$\text{PE}_{\text{max}}$ ( $\text{lm W}^{-1}$ ) (at bias (V))
$\text{Ni}_{0.9}\text{Mg}_{0.1}\text{O}_x$	521	2.12	22,634 (4.8)	5.51 (3.8)	20.51 (3.8)	16.96 (3.8)
$\text{Ni}_{0.9}\text{Mg}_{0.1}\text{O}_x/4\text{PACz}$	521	2.06	29,822 (4.8)	6.76 (3.8)	24.99 (3.8)	20.88 (3.3)
$\text{Ni}_{0.9}\text{Mg}_{0.1}\text{O}_x/4\text{PADCB}$	521	1.96	38,557 (5.3)	14.38 (3.3)	53.61 (3.3)	59.81 (2.8)
$\text{Ni}_{0.9}\text{Mg}_{0.1}\text{O}_x$	487	2.32	1,748 (5.3)	1.07 (3.3)	1.38 (3.3)	1.31 (3.3)
$\text{Ni}_{0.9}\text{Mg}_{0.1}\text{O}_x/4\text{PADCB}$	487	2.29	1,049 (5.3)	3.31 (2.8)	4.00 (2.8)	4.94 (2.3)

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176 **Table S2.** Summarized PeLED characteristics with and without SAM interlayers on  $\text{NiMgO}_x$ .